



WEST Search History

DATE: Thursday, November 18, 2004

<u>Set Name</u>	<u>Query</u>	<u>Hit Count</u>
<i>DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=NO; OP=ADJ</i>		
L12	l8 and ((control or controlling or adjust or adjusting) near4 (conductivity))	189
L11	"tau.sup.1/2 "	17
L10	".tau."	0
L9	tau	40558
L8	(400 or 450 or 500 or 550 or 600 or 650 or 700 or 750 or 800 or 850 or 900) l1	3471
L7	light emission index or light irradiation index	9
L6	20021120	55
L5	l3 same L4	86
L4	semiconductor or wafer or work piece or workpiece	1801842
L3	l1 same L2	618
L2	ns	470695
<i>DB=PGPB,USPT,USOC,EPAB,JPAB,DWPI,TDBD; PLUR=YES; OP=ADJ</i>		
L1	(J or mJ) "cm.sup.2 "	15645

END OF SEARCH HISTORY